

DOCKET NUMBER: 198322US2CONT/mmb

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:
Takahiro HORIKOSHI, et al.

: GROUP: 2851

SERIAL NUMBER: 09/680,513



: ATTENTION:
Application Division
Customer Corrections

FILED: October 6, 2000

FOR: EXPOSURE METHOD, EXPOSURE APPARATUS AND MAKING METHOD OF
THE APPARATUS, AND DEVICE AND MANUFACTURING METHOD OF THE
DEVICE

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

The Patent Office is requested to provide a corrected Official Filing Receipt for the attached. If you have any questions, please do not hesitate to contact us.

No fees are required. However, in the event that a fee is required, please charge the appropriate amount to our Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE RECD	ATTY DOCKET NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/680,513	10/06/2000	2851	2164	198322USCONT	9	58	11

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FILING RECEIPT



OC000000005656519



Date Mailed: 01/05/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Continuing Data as Claimed by Applicant

Foreign Applications

PCT/JP99/01802 04/06/1999

If Required, Foreign Filing License Granted 12/11/2000

Title

Exposure method, exposure apparatus and making method of the apparatus, and device and manufacturing method of the device

Preliminary Class

355

Data entry by : MASON, JAMES

Team : OIPE

Date: 01/05/2001



PLEASE NOTE THAT THE CONTINUING DATA INFORMATION HAS BEEN OMITTED.
IT SHOULD READ AS FOLLOWS:

THIS APPLN IS A 371 OF PCT/JP99/01802 04/06/1999

PLEASE NOTE THAT THE FOREIGN APPLICATION INFORMATION IS INCORRECT. IT
SHOULD READ AS FOLLOWS:

JAPAN	10-111406	04/07/1998
JAPAN	10-125272	04/20/1998

